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Declaration

I, Nicholas Hartmann, translator, having an office at 611 N. Broadway, Suite 509, Milwaukee, WI, 53202, declare that I am well acquainted with the English and German languages and certified by the American Translators Association in translation from German to English, and that the appended document is a true and faithful translation of:

International Patent Application PCT/EP2005/002832, entitled

“Verfahren und Anordnung zur Kühlung eines Substrats, insbesondere eines Halbleiters”

[Method and arrangement for cooling a substrate, especially a semiconductor].

All statements made herein are to my own knowledge true, and all statements made on information and belief are believed to be true; and further, these statements are made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States Code, and that such willful false statements may jeopardize the validity of the document.

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METHOD AND ARRANGEMENT FOR COOLING A SUBSTRATE, ESPECIALLY A SEMICONDUCTOR

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The invention relates to a method and an arrangement for cooling a substrate. A semiconductor, e.g. a microprocessor, microcomputer, or the like, preferably serves as a substrate to be cooled.

A cooling arrangement for a CPU is known from US 6,549,408 B2. Disposed on this arrangement is an evaporator, and coolant in this evaporator is evaporated by the heat of the CPU and thereby flows upward in a riser conduit to a condenser that is arranged at a higher geodetic level. The vapor is cooled and liquefied there, and flows in response to gravity through a downpipe back to the evaporator, where it is evaporated again.

The advantage of such an arrangement is that it operates quietly; a disadvantage, however, is that, according to the second law of thermodynamics, it is impossible in this case to achieve a coolant temperature lower than the ambient temperature, since heat flows only from a higher-temperature medium to a lower-temperature medium. What is obtained instead is a coolant temperature that, because of the temperature gradient necessary for heat transfer, is at least 7 to 10 K (= Kelvin) above ambient temperature; this limits heat dissipation from the CPU, especially on hot days. The overall efficiency of such a system is moreover not good.

It is therefore an object of the invention to make available a novel method and a novel arrangement for cooling a substrate.

According to the invention, this object is achieved by the method according to Claim 1.

What is achieved thereby is that the refrigerant is present at the heat transmission surface of the evaporator substantially in the form of a boiling liquid on which wet vapor is superimposed, thus resulting in outstanding heat transmission that is even better than with liquid cooling; lower substrate temperatures can also be achieved because of the greater average logarithmic heat transfer temperature difference that is possible here. No substantial temperature differences occur in the refrigerant in the evaporator, i.e. only a slight superheating of the refrigerant takes place during heat transfer from the substrate to the refrigerant, since what is transferred is almost exclusively latent heat (resulting from a phase change).

This ensures a largely uniform and low evaporator temperature, and therefore also a correspondingly uniform and low temperature for the substrate to be cooled. This makes possible a high cooling capacity in a small space.

Another manner of achieving the stated object is evident from a cooling arrangement according to Claim 5.

A cooling arrangement of this kind can be designed in very compact and efficient fashion, and is therefore very suitable, for example, for servers and similar applications.

Further details and advantageous refinements of the invention are evident from the exemplifying embodiment, in no way to be understood as a limitation of the invention, that is described below and depicted in the drawings, and from the dependent claims. In the drawings:

FIG. 1 depicts an exemplifying embodiment of a refrigerating arrangement according to the present invention, viewed along line I-I of FIG. 2;

FIG. 2 is a different depiction of the arrangement according to FIG. 1;

FIG. 3 schematically depicts the refrigeration circuit in the arrangement according to FIGS. 1 and 2;

FIG. 4 depicts the circular process using refrigerant in a log-p/h diagram, a considerably improved heat flow from the substrate to the refrigerant being possible;

FIG. 5 is a diagram showing the change in temperature in the course of the circular process; and

FIG. 6 is a section through a preferred embodiment of a high-performance evaporator that can be operated in position-independent fashion.

FIG. 1 schematically shows a section through a preferred embodiment of a cooling apparatus according to the invention. Indicated schematically in FIGS. 1 and 2 is a component 12 to be cooled, e.g. a microprocessor, whose heat produced during operation is to be discharged at a low, uniform temperature so as to enable, in a compact design, reliable operation and a long service life in a context of high heat output. Component 12 is usually arranged in a carrier 12a that serves for electrical connection.

Fan 20 has a fan housing 22, a stator 26 mounted thereon via a plurality of spokes 24, and a rotor 28 having fan blades.

A refrigerant compressor 32 has a magnet cup 34 joined to rotor 28 of fan 20, also a compressor housing 36 and a schematically indicated compressor rotor 38, as well as a drive motor 42, preferably a controllable-speed brushless motor.

Compressor housing 36 is joined via a retaining spider 40 to fan housing 22 to form one assembly. Alternatively, compressor 32 can be arranged on the opposite side of fan 20, i.e. its flange side.

A condenser 44 is connected, in the side opposite compressor 32, to the assembly constituted by fan 20 and compressor 32, so that the air delivered by fan 20 flows through condenser 28 and cools it. Alternatively, condenser 44 could also be arranged on the same side as compressor 32.

Compressor 32 is driven by rotor 28 of fan 30 via magnet cup 34 (magnetic coupling). (Alternatively, fan rotor 28 can be driven, via a magnetic coupling, by the rotor of a drive motor for compressor 32.) Magnet cup 34 is fixedly joined to rotor 28. Compressor housing 36 is retained by retaining spider 40 so that it cannot rotate along with magnet cup 34. Compressor rotor 38 is rotatably journaled in housing 36. Magnet cup 34 is likewise journaled by compressor housing 36.

When magnet cup 34 is rotated by motor 42 of fan 20, compressor rotor 38 is thus also moved and causes compression of refrigerant 52.

The cooling apparatus preferably has a rotation speed controller 54 (FIG. 2) to regulate the rotation speed of fan 20 and/or compressor 32. The target rotation speed for the rotation speed controller is preferably determined as a function of a temperature value that is ascertained by means of a temperature sensor 56 that can be arranged, for example, on component 12.

Compressor 32 draws in saturated refrigerant vapor 52d, or slightly superheated vapor, from an evaporator 60 through a conduit 66. As a result, the necessary evaporation enthalpy q_0 is withdrawn from refrigerant 52 in evaporator 60 (cf. FIG. 4). A further delivery of evaporation enthalpy q_0 occurs by means of the heat output of substrate 12 to be cooled, e.g. a microprocessor to be cooled. Evaporator 60 is preferably somewhat larger than substrate 12.

Be it noted that evaporators 60, 60' in FIGS. 1 and 2 are depicted only in highly schematic form, as is useful for an understanding of the invention.

FIG. 1 shows the manner in which a stratification occurs in practical use in evaporator 60; i.e. at the latter's base and directly above component 12 to be cooled, boiling refrigerant 52a, i.e. a liquid, is present at least in certain regions (similarly to boiling water in a pot), and above it lies wet vapor 52d, comparable to the wet steam in and above boiling water. Superheated vapor may occasionally also be present locally, for example in the context of very strong local heat evolution in substrate 12.

Because the refrigerant is present at the heat transfer surface of evaporator 60 principally as a boiling liquid 52a that has everywhere the same pressure p_v and therefore (since it is in the wet-vapor region) also the same temperature t_v , the heat transition coefficient k is also very good and is substantially the same over the entire heat transfer area. Because the temperature t_v (and evaporator pressure p_v) in evaporator 60 can also be selected to be low, e.g. -10°C , very good cooling of substrate 12 is obtained. In this context, t_v can preferably be regulated to a predetermined value, e.g. to -10°C , to allow e.g. a continuously high clock frequency in a processor 12.

The cooling of substrate 12 can be further improved by designing evaporator 60 appropriately, e.g. by providing, in its interior, cooling ribs or the like which enlarge the heat transfer area and/or increase turbulence (cf. FIG. 6 below in this connection).

Because the temperature of substrate 12 is usually highest at its center, it can be very advantageous to deliver the refrigerant to the center of evaporator 60 and extract it to compressor 32 at the edge of evaporator 60. These special features are depicted in FIG. 6. Be it noted here that there are numerous advantageous configurations for such evaporators, which configurations can advantageously be used within the scope of the invention in order to achieve a particularly compact design and high-efficiency cooling.

During cooling, a temperature gradient is created between substrate 12, evaporator 60, and refrigerant 52a, 52d in evaporator 60. To achieve a very high heat flux density dQ/dt with very small heat transfer areas, the temperature gradient is increased by reducing the temperature in the heat

absorber, i.e. in this case the temperature of refrigerant 52a, 52d in evaporator 60, as far as is necessary; the maximum microprocessor temperature is of course limited depending on its type, so that increasing the temperature gradient by increasing the temperature of the microprocessor usually does not represent a practical alternative.

The use of a refrigerant circuit such as the one depicted schematically in FIGS. 3 to 5 allows a temperature t_v of, for example, -10°C to be obtained in evaporator 60 with an ambient temperature of $+30^{\circ}\text{C}$, in other words a very steep temperature gradient and consequently a very high heat flux even with small transfer areas. This is explained once again below with reference to equation (1).

Compressor 32 compresses the aspirated refrigerant 52d to a condensation pressure p_k , thus yielding at its outlet a temperature t_2 (FIG. 5) that is well above the respective ambient temperature t_u (FIG. 5). The compressed, superheated refrigerant 52b (FIG. 2) is guided via a conduit 68 to condenser 44 and through it, so that it can lose heat therein and condense.

Fan 20 blows or draws air (at ambient temperature t_u) through the air side of condenser 44, and this air cools condenser 44 and therefore also the superheated refrigerant 52b in it. Sufficient heat q (cf. FIG. 4) is withdrawn from refrigerant 52b that it completely condenses and may, if applicable, even be slightly subcooled, for example by 5°K . The refrigerant condensate is labeled 52c. It is still approximately at the high condensation pressure p_k (FIG. 4), i.e. point 3 of FIGS. 3 and 4, which is associated with a correspondingly high temperature t_k of, for example, 45°C . This condensate 52c is delivered via conduit 64 to a throttle valve 62 and expanded therein isenthalpically, i.e. at a substantially constant enthalpy, to the evaporation pressure p_v (cf. point 4 in FIG. 4). Associated with this evaporation pressure p_v is a correspondingly low evaporator temperature t_v of, for example, -10°C , as used for cooling substrate 12.

Instead of a single evaporator 60, for example, two evaporators 60, 60' can be used that preferably are connected in parallel but can also be connected in series (cf. FIG. 3).

FIG. 3 schematically depicts the refrigeration circuit as a "circuit diagram." Because a refrigerant 52 is used, e.g. 1,1,1,2-tetrafluoroethane (commercial designation H-FKW 134a or R 234a) or, for example, the refrigerant R600a, this agent is present in the circuit according to FIG. 3 in two phases, namely gaseous and liquid. In evaporators 60, 60', refrigerant 52 is present as a wet vapor (made up of boiling liquid 52a and saturated vapor, in some cases also with slightly superheated vapor).

In condenser 44, the refrigerant is present as superheated vapor and as wet vapor, and as subcooled liquid. These are, in FIGS. 3 and 4, the segments between the points labeled 2 and 3 (condenser 44) and 4 and 1 (evaporator 60). A segment at a substantially constant pressure p_K occurs between points 2 and 3. A considerably improved heat transmission from evaporator 60, 60' to refrigerant 52a therein (i.e. an improved α) is therefore achievable, and thus a considerably higher heat flux density, in particular from heat source 12 to evaporator(s) 60, 60', with no change in the temperature of heat source 12.

An isenthalpic change of state occurs in throttle 62 (cf. the vertical line between points 3 and 4 in the diagram of FIG. 4), i.e. no energy is delivered or removed, but the pressure and temperature of the refrigerant are simply reduced to the lower level in evaporator 60. The aggregate state of the subcooled refrigerant condensate 52c likewise changes in this context, from subcooled liquid (point 3 in FIGS. 3 and 4) to wet vapor (point 4 in FIGS. 3 and 4). This is therefore, as depicted in FIG. 4, a counterclockwise circular process. The letter **h** therein designates the enthalpy measured in kJ per kg of refrigerant, and the letter **p** designates the pressure in bar.

In FIG. 4, 70 designates the boiling line that separates a region 72 of pure liquid from a wet-vapor region 74. The dew line, which separates region 74 from hot-vapor region 78, is labeled 76. The so-called critical point is labeled 80. In the region above this point 80, a precise separation between liquid and hot vapor is no longer possible. The associated critical temperature consequently limits the range of application of the selected refrigerant.

The temperatures of evaporators 60, 60' can be varied in this context, and can even be decreased below the ambient temperature. A further considerable increase in the heat flux density from heat source 12 to an evaporator 60, 60' is thereby achievable, with no need to raise the temperature of heat source 12 for that purpose. If the evaporator temperature t_v is decreased below the dewpoint temperature of the ambient air, thermal insulation 86 of the cold components -- i.e., as depicted, of throttle valve 62, evaporator 60, and connecting conduit 66 to compressor 32 -- is useful. This prevents water from condensing out of the ambient air onto the cold components, which could result in difficulties with electrical parts.

Refrigerant 52a, 52d is present in evaporator 60 at a substantially constant temperature, i.e. during heat transfer no substantial temperature gradient occurs in refrigerant 52 itself except for a slight superheating (equivalent to, for example, 5° K) in evaporator 60, since what is transferred here is almost exclusively latent heat (phase change). A largely uniform and low temperature is thereby ensured for evaporator 60, 60', as is desirable for reliable cooling of semiconductor substrates.

Also contributing to this is the fact that, as depicted in FIGS. 1 and 6, the heat transfer surfaces of evaporators 60 and 100 are covered mainly with boiling liquid 52a.

FIG. 5 shows the change in temperature as a function of travel L through the refrigeration circuit. The travel L is plotted symbolically in FIG. 3, and is based on the idea that an observer is traveling along with the refrigerant and finally arrives back at his starting point. This is a type of illustration that is commonly used for such systems. Points 1, 2, 3, and 4 are the same as those indicated in the preceding Figures.

At point 4, namely the inlet into evaporator 60, 60', the refrigerant is at its lowest temperature t_v (evaporator temperature), e.g. -10°C , i.e. it is present chiefly as wet vapor, which is very favorable for heat transfer. "Wet vapor" is understood to be a mixture of boiling liquid and saturated vapor. An illustrative instance of wet vapor is a pot of boiling water at standard atmospheric pressure. The boiling water stays at its temperature of 100°C until it has completely evaporated. Now consider FIG. 5: here, in the same fashion, the refrigerant stays at this temperature t_v of, for example, -10°C in a region 78 until it reaches a point 80, namely its dew line; and in the region 82 between point 80 and point 1, a slight superheating of the wet vapor can take place (equivalent to, for example, 5°K), with the result that the temperature of the refrigerant can rise somewhat in this region 82. Because the refrigerant is present here substantially as wet vapor, the heat transition coefficient k is elevated (cf. equation (1) below and the explanations thereof).

Between points 1 and 2, compressor 32 is effective, causing at point 2 a corresponding rise in pressure and temperature, the latter reaching its maximum t_2 at the outlet of compressor 32. There the refrigerant is present as a compressed superheated vapor.

Between points 2 and 3, the refrigerant flows through condenser 44. There it is cooled so that its temperature first drops, between point 2 and a point 84 (i.e. where the dew line is reached) in a region 86, to the condensation temperature t_k . Because of the continued heat discharge as a result of cooling in condenser 44, complete condensation of the refrigerant occurs between points 84 and 90 until boiling line 90 is reached, a corresponding quantity of heat q (FIG. 4) being withdrawn from the refrigerant. A slight subcooling of the refrigerant (equivalent to, for example, 5° K) can also occur between points 90 and 3 in a region 92.

Be it noted that the condensation temperature t_k is considerably (e.g. 10° K) above the ambient temperature t_v ; this correspondingly improves heat transmission from condenser 44 to the ambient air (cf. FIG. 5).

Between points 3 and 4, the condensed refrigerant flows through throttle 62, and at the latter's outlet, the agent's temperature has dropped back to the evaporator temperature t_v , which can be, for example, -10° C and remains practically constant in evaporators 60, 60' in region 78 for the reasons explained; at most, a slight temperature rise of 5° K can occur in region 82 as a result of superheating. This enables excellent heat transmission from processor 12 to refrigerant 52, since a higher and substantially constant temperature gradient exists at processor 12, so that cooling is equally good everywhere. If processor 12 is at, for example, a temperature of $+60^\circ \text{ C}$, and the refrigerant has an evaporator temperature t_v of -10° C , the result is a substantially constant temperature gradient of 70° K , which enables excellent cooling, even in a small volume.

It is very advantageous that a low temperature exists practically only between points 4 and 1 of the refrigeration circuit, i.e. thermal insulation 86 is necessary only in this region, but not on condenser 44 or compressor 32. This is a consequence of the fact that condenser 44 operates at a condensation temperature t_k that is, for example, $+45^\circ \text{ C}$ or higher. Even with a slight subcooling of 5° K in region 92, the temperature there can still be kept at $+40^\circ \text{ C}$, i.e. above the dewpoint temperature of the ambient air, so that no condensation of moisture from the air can occur there. This emerges as a very important factor specifically in arrangements for cooling electronic components, since moisture that has condensed out onto them could cause malfunctions.

Expressed mathematically, the heat flux to be transferred is calculated as:

$$dQ/dt = k * A * \Delta\theta_m \quad (1),$$

in which:

dQ/dt = heat flux in W,

k = heat transition coefficient in $\text{W/m}^2\text{K}$,

A = heat transfer area in m^2 ,

$\Delta\theta_m$ = mean logarithmic heat transfer temperature difference

In the context of the invention, heat transfer area A has a fixed value. A considerable increase in heat flux dQ/dt is obtained, in the invention, thanks to the following factors:

a) the heat transition coefficient k is greatly increased because heat is transferred substantially in the wet-vapor region.

b) the mean logarithmic temperature difference $\Delta\theta_m$ is greatly increased because the evaporator temperature can be lowered to well below ambient temperature, even with no change in the temperature of substrate 12 or 106 (FIG. 6).

FIG. 6 is a section through an advantageous evaporator 100. As a result of its construction, this can be operated in a substantially position-independent fashion. It works on the principle of an impact plate in order to achieve a high heat flux density.

Evaporator 100 has an upper part 102 that is usually manufactured, in one piece and as an injection-molded part, from a suitable plastic, and it has a refrigerating plate 104 made of a suitable metal, usually copper, that is implemented for contact against a heat-generating substrate 106 that is arranged in a carrier 108 (for the electrical connections of substrate 106). Refrigerating plate 104 can be manufactured, for example, as a cold-extruded part made of copper, aluminum, silver, or the like. This allows refrigerating plate 104 to be manufactured simply and economically, whereas the upper part can have a more complex configuration and is nevertheless easy to manufacture.

Refrigerating plate 104 has a heat-transferring surface 110 that has a high surface quality and rests over its entire surface against substrate 106, some thermoconductive paste 111 usually being inserted between surface 110 and substrate 106. The heat delivery dq/dt from substrate 106 is depicted symbolically by arrows, in order to illustrate the heat flux.

Upper part 102 has, at its center 112, a delivery conduit 112 at whose lower end nozzles 114 are preferably located. Expanded refrigerant 52 is delivered through delivery conduit 112 as wet vapor, and is sprayed through nozzles 114 onto refrigerating plate 104. This causes an increase in turbulence and an additional improvement in heat transmission from refrigerating plate 104 to refrigerant 52. Nozzles 114 can be, for example, orifice nozzles or slit nozzles.

Refrigerating plate 104 has a dish-shaped depression 114 having, for example, the outline of a spherical shell, a paraboloid of rotation, a bowl, or the like. From this depression 114, needle-shaped cooling elements 116 project upward, as far as a plane 118 that extends parallel to surface 110, as FIG. 6 clearly shows. Cooling elements 116 can also be implemented, as necessary, as ribs or the like, as is known to one skilled in the art, and their height can be varied.

Located between the needle-shaped cooling elements 116 are cooling channels 120, and wet vapor 52 is sprayed into these in the manner of an impinging flow, thus resulting in good heat transmission. The impinging flow makes it possible to achieve, in a very small space, a very high heat flux density that can be increased even further by the low refrigerant temperature. Nozzles 114 make possible a vena contracta (Coanda effect) that likewise contributes to an improvement in heat transfer.

As is evident, it is irrelevant whether evaporator 100 according to FIG. 6 is exactly horizontal or is in a slightly oblique position, since this results in no substantial change in the heat transfer from refrigerating plate 104 to wet vapor 52. This represents a great advantage of the arrangement according to FIG. 6, since in practical use it cannot be expected that, for example, a computer of which microprocessor 106 is a component will be set up entirely horizontally.

Arranged approximately concentrically with delivery conduit 112, on underside 122 of upper part 102, is an annular baffle 124 that projects downward and preferably rests against the upper ends of cooling elements 116 there, or indeed protrudes slightly into channels 120. Wet vapor 52 is thereby forced to flow from the center through channels 120 radially outward in all directions, which additionally improves heat transfer. Without baffle 124, wet vapor 52 would flow, for the most part, directly from inlet 112 to an outlet channel 126, and not in between cooling elements 116.

Outlet channel 126 is provided in upper part 102. Its center axis 128 extends approximately so that it extends through outer rim 130 of the (preferably circular) refrigerating plate 104.

Upper part 102 has an extension 132 that extends downward in approximately tubular fashion and approximately concentrically with inlet 112; in this extension 132, refrigerating plate 104 is mounted in sealed fashion, e.g. by means of a peripheral seal 134 or by adhesive bonding, welding, soldering, or the like.

When wet vapor 52 flows through channels 120 between cooling elements 116, it evaporates, so that saturated vapor 52 or superheated vapor emerges through outlet 126. A drier 138 is usually placed downstream in order to separate out entrained liquid particles, since they might damage compressor 32.

Evaporator 100 also has an integrated peripheral installation plate or flange 140 with which it can be mounted on a substrate 106. Known mounting methods can be used for mounting.

Numerous variants and modifications are of course possible within the scope of the present invention.